

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants: Luetzen, *et al.*

Docket No.: INF 2004 SP 00115 US

Serial No.: 10/721,225

Art Unit: 1763

Filed: November 26, 2003

Examiner: Goudreau, George A.

For: Method and Structures for Increasing the Structure Density and the Storage Capacitance in a Semiconductor Wafer

Mail Stop Amendment
Commissioner for Patents
P. O. Box 1450
Alexandria, VA 22313-1450

AMENDMENT

Dear Sir:

The following amendments and remarks are presented in response to the Examiner's Office Action mailed May 17, 2007. Please amend the above-referenced application as follows.